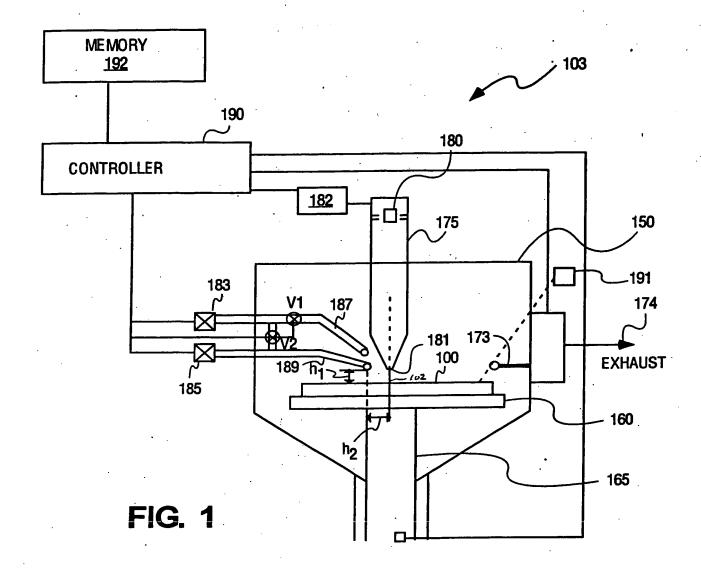
Blakely, Sokoloff, Taylor & Zafman LLP Title: FOCUSED ION BEAM DEPOSITION 1st Named Inventor: Ilan Gavish Express Mail No.: EV339905685US Sheet: 1 of 3

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Docket No.: 42P10059CD

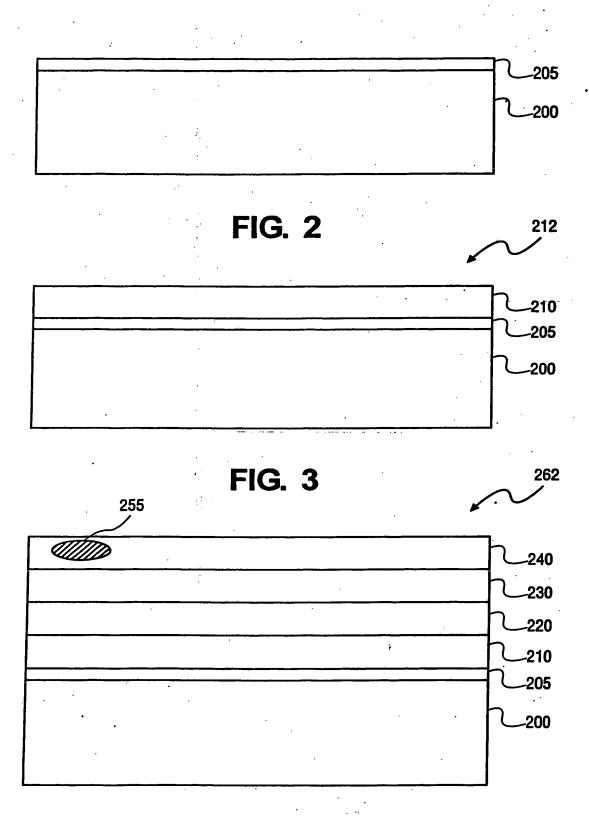


FIG. 4

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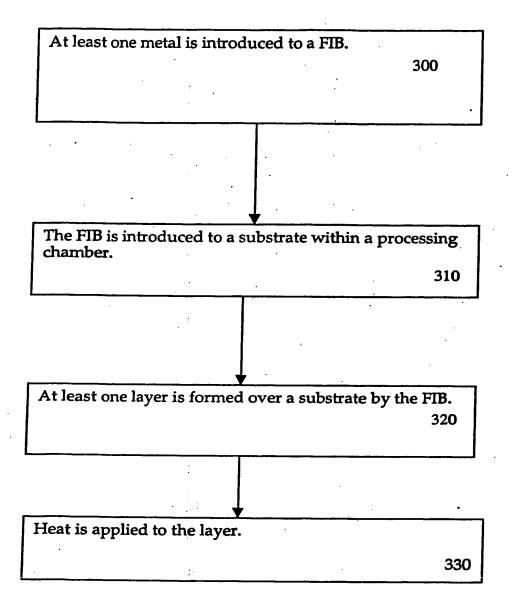


Fig. 5